

PATENT APPLICATION
IN THE U.S. PATENT AND TRADEMARK OFFICE

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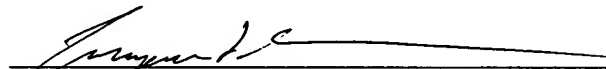
Applicants : Yuji AKIMOTO et al
Title : METHOD FOR MANUFACTURING
HIGHLY-CRYSTALLIZED OXIDE POWDER
Serial No. : 10/630 394 Group: 1765
Confirmation No.: 8363
Filed : July 30, 2003 Examiner: Kunemund
Atty. Docket No.: Komatsu 290
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 27, 2005.


Terryence F. Chapman

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	Donald J. Wallace	Reg. No. 43 977
	Kevin L. Pontius	Reg. No. 37 512
	Sidney B. Williams, Jr.	Reg. No. 24 949

Correspondence: Information Disclosure Statement
dated July 27, 2005
including enclosures listed thereon

190.05/05



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Applicants: Yuji AKIMOTO et al

For: METHOD FOR MANUFACTURING
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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(e)(1) and 1.98, enclosed herewith is a copy of a Chinese Office Action dated April 29, 2005 and a Taiwanese Office Action dated June 7, 2005, Form PTO-1449 and the references cited thereon.

Chinese Patent Publication No. CN1162617A corresponds to U.S. Patent No. 5 851 428 and CN1012725B corresponds to U.S. Patent Nos. 4 929 436 and 5 152 974 which are attached. U.S. Patent Publication No. US2001/0052589A1 cited in the Chinese Office Action corresponds to U.S. Patent No. 6 627 115 cited in the Taiwanese Office Action.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Further consideration is respectfully solicited.

Respectfully submitted,


Terryence F. Chapman

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INFORMATION
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA	5 851 428	12-22-1998	MATSUDA et al
	AB	4 929 436	05-29-1990	LEGRAND et al
	AC	5 152 974	10-06-1992	LEGRAND et al
	AD	2001/0052589 A1	12-20-2001	HAMPDEN-SMITH et al
	AE	6 627 115	09-30-2003	HAMPDEN-SMITH et al
	AF			
	AG			
	AH			
	AI			
	AJ			
	AK			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AL	CN 1162617A	10-22-1997		
	AM	CN 1012725B	06-05-1991		
	AN				
	AO				
	AP				

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AQ	
	AR	
EXAMINER SIGNATURE		DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.